

EV318282203

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/071,456  
Filing Date ..... February 8, 2002  
Inventor ..... David L. Dickerson et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2814  
Examiner ..... A.D. Mai  
Attorney's Docket No. .... MI22-1943  
Title: Semiconductor Constructions of Trenches with Insulative Material (As Amended)

RESPONSE TO JUNE 10, 2003 OFFICE ACTION

To: Mail Stop Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: D. Brent Kenady  
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Spokane, WA 99201-3828

Responsive to the Office Action dated June 10, 2003, Applicant amends  
and remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

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